

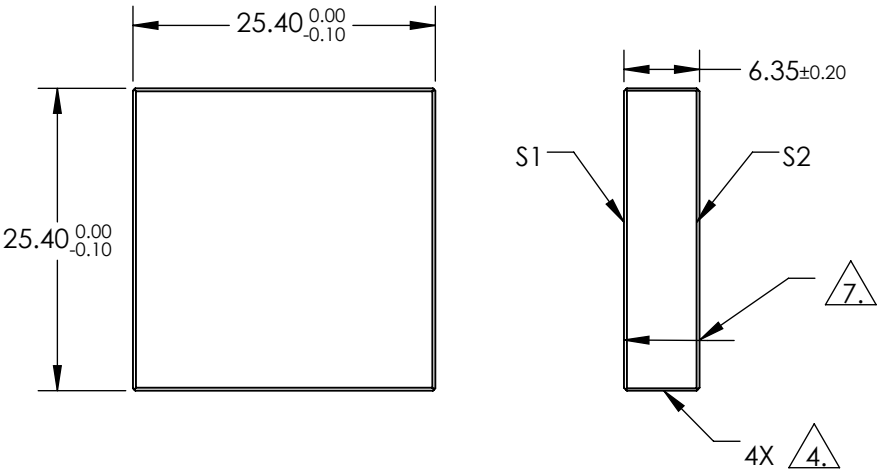
NOTES:

1. SUBSTRATE:
Fused Silica
2. SURFACE S1 TO BE PARALLEL TO SURFACE S2 TO WITHIN <3 ARCMINS
3. COATING (APPLY ACROSS COATING APERTURE)

S1: R(ABS) >99.8% @ 532nm
DAMAGE THRESHOLD,
PULSED: 15 J/cm² @ 1030nm, 20ns, 20Hz

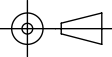
S2: NONE

4. FINE GROUND SURFACE
5. CLEAR APERTURE AND COATING APERTURE ARE CENTERED ON SURFACE
6. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
7. ARROW ON EDGE WITH LASER ETCH, PENCIL, OR PERMANENT INK POINTS TOWARDS SURFACE S1



**FOR INFORMATION ONLY:
DO NOT MANUFACTURE
PARTS TO THIS DRAWING**

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

	S1	S2				
SHAPE	PLANO	PLANO				
SURFACE QUALITY	10-5	COMMERCIAL POLISH				
SURFACE FLATNESS	0.10 WAVE	N/A				
MIN CLEAR APERTURE	21.59 x 21.59	N/A				
MIN COATING APERTURE	21.59 x 21.59	N/A				
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	TITLE	25.4 x 25.4mm 532nm 0-45°, Nd:YAG Laser Line Mirror
					DWG NO	39649
					SHEET 1 OF 1	

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